Docket No.: 60188-622 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Customer Number: 20277 In re Application of

Confirmation Number: Masahiro IMADE, et al.

Serial No.: Group Art Unit:

Filed: July 31, 2003 Examiner:

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the document listed on the attached form PTO-1449. It is respectfully requested that the document be expressly considered during the prosecution of this application, and that the document be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of Japanese Patent Publication No. 11-26571 is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including

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Respectfully submitted,

MCDERMOTT, WILL & EMERY

Michael E. Fogarty Registration No. 36,139

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 MEF:mcw

Facsimile: (202) 756-8087 Date: July 31, 2003

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION					ATTY. DOCKET NO. 60188-622	SE	SERIAL NO.		
•					APPLICANT Masahiro IMADE, et al.				
· (PTO-1449)					FILING DATE GROUP July 31, 2003				
				U.S. PATEN	T DOCUMENTS				
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